

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicants : Sakae KOYATA et al. Group Art Unit: 1765  
Appln. No. : 10/596,177 Examiner: Lan VINH  
Filed : August 17, 2006 Confirmation No.: 3188  
For : METHOD FOR MANUFACTURING SINGLE-SIDE MIRROR  
SURFACE WAFER

**AMENDMENT & RESPONSE UNDER 37 CFR § 1.111**

Commissioner for Patents  
U.S. Patent and Trademark Office  
Customer Service Window, Mail Stop Amendment  
Randolph Building  
401 Dulany Street  
Alexandria VA 22314

Sir:

In response to the Official Action dated July 11, 2007, setting a shortened three-month statutory period for response to expire on October 11, 2007, Applicants respectfully request reconsideration and withdrawal of the outstanding rejection in view of the herein-contained remarks. However, if any extension of time is necessary, this is an express request for any necessary extension of time and authorization to charge any required extension of time fee or any other fees which may be required to preserve the pendency of the present application to Deposit Account No. 19-0089.

**Amendments to the Claims** are reflected in the listing of claims which begin on page 2 of this document.

**Remarks/Arguments** begin on page 5 of this document.